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April 1, 2004

MAIL STOP PATENT APPLICATIONCommissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450Re: Application of Yoshiaki SHIMIZU, Nobuhito TAKAHASHI and Masaru TAKAHASHI
LIQUID EJECTING APPARATUS
Assignee: **SEIKO EPSON CORPORATION**
Our Ref. Q80869

Dear Sir:

Attached hereto is the application identified above comprising twenty-five (25) sheets of the specification, (Japanese language) including the claims and abstract, and fifteen (15) sheets of drawings. **The requisite U.S. Government Filing Fee, copies of the executed Declaration and Power of Attorney and Assignment will be submitted at a later date.**

The Government filing fee is calculated as follows:

Total claims	16 - 20	=		x	\$18.00	=	\$0.00
Independent claims	2 - 3	=		x	\$86.00	=	\$0.00
Base Fee							\$770.00

TOTAL FEE**\$770.00**

Priority is claimed from:

<u>Country</u>	<u>Application No</u>	<u>Filing Date</u>
Japan	2003-98938	April 2, 2003
Japan	2004-99691	March 30, 2004

The priority documents will be filed at a later date.

Respectfully submitted,
SUGHRUE MION, PLLC

Attorneys for Applicant

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